

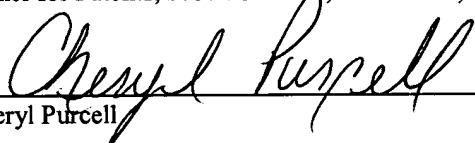
DOCKET NO: VSEA 28-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther et al.  
Serial No: 10/005,613  
Confirmation No: 9731  
Filed: October 26, 2001  
For: HYBRID SCANNING SYSTEM AND METHODS FOR ION  
IMPLANTATION  
Examiner: Rodney Glen McDonald  
Art Unit: 1753

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

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Cheryl Purcell

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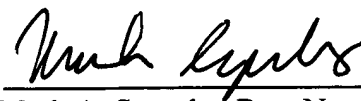
Sir:

Transmitted herewith are the following documents:

- ☒ Response to Final Office Extension
- ☒ Executed Terminal Disclaimer
- ☒ Three-month Petition for Extension of Time
- ☒ Notice of Appeal
- ☒ Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,  
*Steven R. Walther et al., Applicants*

By:   
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